

Attorney Docket No.: YOR920030174US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application

Applicant(s): Babich et al.  
Docket No.: YOR920030174US1  
Serial No.: 10/634,667  
Filed: August 5, 2003  
Group: Unassigned  
Examiner: Unassigned

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Signature: Tina Maurio Date: August 14, 2003

Title: Lithographic Antireflective Hardmask Compositions and Uses Thereof

TRANSMITTAL OF FORMAL DRAWINGS

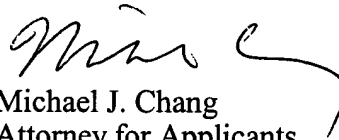
Commissioner for Patents  
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Alexandria, VA 22313-1450

Attention: Official Draftsperson

Sir:

Applicants submit herewith one (1) sheet of formal drawings in the above-referenced application.

Respectfully submitted,



Date: August 14, 2003

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